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APR 2 5 2003

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

A PLANT OF STATE OF S

Heribert WEBER et al

Serial No.

09/699,704

Filed

October 30, 2000

For

MASS FLOW SENSOR HAVING AN IMPROVED

MEMBRANE STABILITY

Art Unit

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2855

Examiner

Martir, Lilybett

**BOX AF** 

Commissioner for Patents Washington, D.C. 20231

Thereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, Washington, D.G. 2023 on Date 2/2 2 2003 Reg. No. 336,197

Jong H. Le

AMENDMENT

SIR:

This paper addresses the Final Office Action dated December 2, 2002.

Applicants respectfully request reconsideration in view of the amendments and remarks below.

## **IN THE CLAIMS:**

Without prejudice, please cancel claim 2 and please amend claims 1, 3, and 8-12 as follows.

- 1. (Once Amended) A mass flow sensor, comprising:
  - a frame formed at least in part by silicon;
  - a membrane held by the frame;
  - a metal layer including a first structure and a second structure and being arranged above the frame;
    - a heating element formed by the first structure in the metal layer;

